



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: STADLER ET AL - 3

SERIAL NO.: 10/686,365

GROUP: 1763

FILED: OCTOBER 15, 2003

TITLE: PROCESS AND DEVICE FOR THE WET-CHEMICAL TREATMENT  
OF SILICON

**SUBMISSION OF INFORMATION DISCLOSURE STATEMENT  
OF CHRISTIAN BAAR**

MAIL STOP MISSING PARTS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the attached Information Disclosure Statement, duly signed by Christian Baar, and the references listed on the enclosed Form PTO-1449 and attached thereto. The enclosed references are believed to be material to the examination of the above-identified application.

It is respectfully requested that the foregoing Information Disclosure Statement (IDS) be incorporated into the official file of the present patent application.

Respectfully submitted,  
Maximilian STADLER ET AL - 3

Allison C. Collard, Reg.No.22,532  
Edward R. Freedman, Reg.No.26,048  
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ERC:djp

Encs: Information Disclosure Statement of Christian Baar  
Form PTO-1449 w/copies of three (3) references

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, Alexandria, VA 22313-1450 on March 11, 2004.

  
\_\_\_\_\_  
Maria Guastella



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

STADLER ET AL.-3:

Serial Number: 10/686,365

Group Art Unit: 1763

Filed: October 15, 2003

For: PROCESS AND DEVICE FOR THE WET-CHEMICAL TREATMENT OF SILICON

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir or Madam:

I, Christian Baar, associated with the preparation and prosecution of the above-identified application, residing at Maxlrainstr. 6, 81541 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the enclosed application and in the Office Action of the German Patent and Trademark Office and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

US 5,843,322 is already in English language.

For DE 2 013 830 an English Derwent Abstract is enclosed.

Signed this 19<sup>th</sup> day of November, 2003.

  
.....  
Dr. Christian Baar

FORM PTO 1449 (REV. 7-80) MAR 15 2004 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.: ST 10114

SERIAL NO. 10 1686, 365

APPLICANT: Stadler et al. - 3

FILING DATE: Oct. 15, 2003 GROUP: 1763

## LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	5,843,322	12/1/98	Chandler, Jr.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL	2 013 830	10/7/71	Germany				
	AM							
	AN							
	AO							
	AP							

## OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		English Derwent Abstract AN 1971- 650625
			corresponding to DE 2 013 830
	AS		
	AT		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.